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| <b>Search Notes</b><br> | <b>Application/Control No.</b><br>10583167 | <b>Applicant(s)/Patent Under Reexamination</b><br>KIM ET AL. |
|  | <b>Examiner</b><br>Joey Bednash            | <b>Art Unit</b><br>2461                                      |

| SEARCHED |          |           |              |
|----------|----------|-----------|--------------|
| Class    | Subclass | Date      | Examiner     |
| 370      | 352      | 3/25/2010 | Joey Bednash |
| 375      | 219      | 3/25/2010 | Joey Bednash |
| 709      | 225      | 3/25/2010 | Joey Bednash |

| SEARCH NOTES                 |  |           |              |
|------------------------------|--|-----------|--------------|
| Search Notes                 |  | Date      | Examiner     |
| East search history attached |  | 3/25/2010 | Joey Bednash |
| Inventor search in eDAN      |  | 3/25/2010 | Joey Bednash |
| Inventor search in eDAN      |  | 9/11/2010 | Joey Bednash |
| Inventor search in eDAN      |  | 2/12/2011 | Joey Bednash |
| updated search               |  | 2/12/2011 | Joey Bednash |

| INTERFERENCE SEARCH |          |      |          |
|---------------------|----------|------|----------|
| Class               | Subclass | Date | Examiner |
|                     |          |      |          |

/Joey Bednash/  
Examiner, Art Unit 2461